

DOCKET NO.: 288649US0PCT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

GROUP: 1753

Chiho ITOU, et al.

SERIAL NO: 10/573,158

ATTENTION:
FILING RECEIPT CORRECTIONS

FILED: November 13, 2006

FOR: CATAPHORESIS APPARATUS, CATAPHORESIS METHOD, AND
DETECTION METHOD FOR ORGANISM-RELATED MATERIAL USING
THE APPARATUS AND THE METHOD

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Office of Initial Patent Examination
Commissioner for Patents
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Sir:

The Patent Office is requested to provide a corrected Official Filing Receipt for the following.

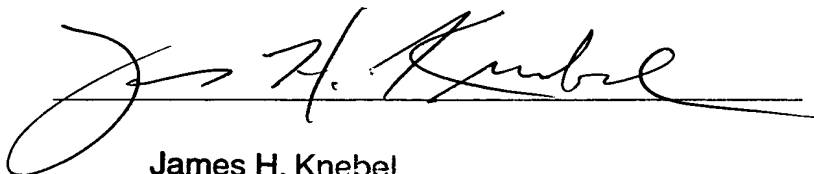
PLEASE NOTE THAT THE ASSIGNMENT FOR PUBLISHED PATENT APPLICATION DATA IS MISSING. IT SHOULD READ AS FOLLOWS:

MITSUBISHI RAYON CO., LTD, TOKYO, JAPAN.

No fees are required. If you have any questions, please do not hesitate to contact us.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.
Norman F. Oblon

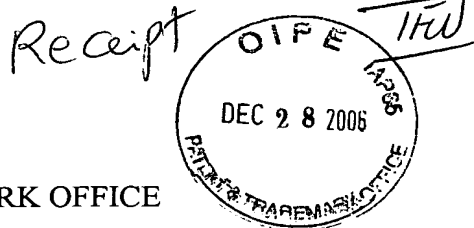


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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/573,158	11/13/2006	1753	1990	288649US0PCT	8	17	2

CONFIRMATION NO. 6571

FILING RECEIPT



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22850
C. IRVIN MCCLELLAND
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ALEXANDRIA, VA 22314

Date Mailed: 12/01/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

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7) *Assignment for published patent Application*
Power of Attorney: The patent practitioners associated with Customer Number **22850**.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/14097 09/27/2004

Foreign Applications

JAPAN 2003-335782 09/26/2003

RECEIVED: 12/4/06
OBLON, SPIVAK, MCCLELLAND
MAIER & NEUSTADT, P.C.

DOCKETING DEPT.

Initials/Date Docketed: dp/12/5/06
Type of Resp(s): _____
Due Date(s): _____

If Required, Foreign Filing License Granted: 11/30/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/573,158**

Projected Publication Date: 03/08/2007

4 *Mitsubishi Rayon Co., LTD, Tokyo, Japan*

Non-Publication Request: No

Early Publication Request: No

Title

Cataphoresis apparatus cataphoresis method, and detection method for organism-related material using the apparatus and the method

Preliminary Class

204

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